

10/529633

JC13 Rec CT/PTO 31 MAR 2005
SHEET 1 OF 1

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 266485US6PCT		SERIAL NO. New U.S. PCT Application Based on PCT/IB03/04420	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Christopher John, Howard WORT, et al.			
				FILING DATE Herewith		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
DM	AA	2002/023733	02/28/02	FOX, Joe R. et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
DM	AO	0 859 408	08/19/98	EP			NO
DM	AP	0 930 378	07/21/99	EP			NO
DM	AQ	0 844 319	05/27/98	EP			NO
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
DM	AW	SUMIO LIJIMA ET AL: "EARLY FORMATION OF CHEMICAL VAPOR DEPOSITION DIAMOND FILMS" APPLIED PHYSICS LETTER, AMERICAN INSTITUTE OF PHYSICS, vol. 57, no. 25, pages 2646-2648, December 17, 1990.					
	AX						
	AY						
	AZ						<input type="checkbox"/> Additional References sheet(s) attached
Examiner /Daniel Miller/					Date Considered 06/23/2007		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							